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FROM: Winston Hsu, PATENT AGENT, REG. NO. : 41,526

SERIAL NO.: 10/707,561

ATTORNEY DOCKET NO.: LKSP0034USA

SUBJECT: INFORMATION DISCLOSURE STATEMENT

TOTAL PAGES: 22 PAGES (INCLUDING COVER PAGE)

Winston Hsu 2004/08/27

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PTO/SB/87 (08-03)

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APPLICATION NUMBER: 10/707,561

PAPERS INCLUDED:

(1) Transmittal Form	1 PAGE
(2) Fee Transmittal	1 PAGE
(3) Information Disclosure Statement	20 PAGES

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TRANSMITTAL FORM (to be used for all correspondence after initial filing)	Application Number	10/707,561	
	Filing Date	12/22/2003	
	First Named Inventor	Mu-Jung Wu	
	Art Unit	2812	
	Examiner Name		
Total Number of Pages in This Submission	20	Attorney Docket Number	LKSP0034USA

ENCLOSURES (Check all that apply)		
<input checked="" type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment/Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input checked="" type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s) _____	<input type="checkbox"/> After Allowance communication to Technology Center (TC) <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input type="checkbox"/> Other Enclosure(s) (please identify below):
Remarks		
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT		
Firm or Individual name	Winston Hsu, Reg. No.: 41,526	
Signature	<i>Winston Hsu</i>	
Date	8/27/2004	

CERTIFICATE OF TRANSMISSION/MAILING		
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Signature		Date

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PTO/SB/17 (10-03)

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FEE TRANSMITTAL
for FY 2004

Effective 10/01/2003. Patent fees are subject to annual revision.

☐ Applicant claims small entity status. See 37 CFR 1.27**TOTAL AMOUNT OF PAYMENT** (\$) 0.00**Complete if Known**

Application Number	10/707,561
Filing Date	12/22/2003
First Named Inventor	Mu-Jung Wu
Examiner Name	
Art Unit	2812
Attorney Docket No.	LKSP0034USA

METHOD OF PAYMENT (check all that apply)☐ Check ☐ Credit card ☐ Money Order ☐ Other ☐ None☒ Deposit Account:Deposit Account Number: 50-3105
Deposit Account Name: North America Intellectual Property Corp.

The Director is authorized to: (check all that apply)

☒ Charge fee(s) indicated below ☒ Credit any overpayments☒ Charge any additional fee(s) or any underpayment of fee(s)☐ Charge fee(s) indicated below, except for the filing fee to the above-identified deposit account.**FEE CALCULATION****1. BASIC FILING FEE**

Large Entity Fee Code (\$)	Small Entity Fee Code (\$)	Fee Description	Fee Paid
1001 770	2001 385	Utility filing fee	
1002 340	2002 170	Design filing fee	
1003 530	2003 265	Plant filing fee	
1004 770	2004 385	Reissue filing fee	
1005 160	2005 80	Provisional filing fee	
SUBTOTAL (1)			(\$) 0.00

2. EXTRA CLAIM FEES FOR UTILITY AND REISSUE

Large Entity Fee Code (\$)	Small Entity Fee Code (\$)	Fee Description	Fee Paid
1202 18	2202 9	Claims in excess of 20	
1201 88	2201 43	Independent claims in excess of 3	
1203 290	2203 145	Multiple dependent claim, if not paid	
1204 88	2204 43	** Reissue independent claims over original patent	
1205 18	2205 9	** Reissue claims in excess of 20 and over original patent	
SUBTOTAL (2)			(\$) 0.00

**or number previously paid, if greater. For Reissues, see above

FEE CALCULATION (continued)**3. ADDITIONAL FEES**

Large Entity Fee Code (\$)	Small Entity Fee Code (\$)	Fee Description	Fee Paid
1051 130	2051 65	Surcharge - late filing fee or oath	
1052 50	2052 25	Surcharge - late provisional filing fee or cover sheet	
1053 130	1053 130	Non-English specification	
1812 2,520	1812 2,520	For filing a request for <i>ex parte</i> reexamination	
1804 920*	1804 920*	Requesting publication of SIR prior to Examiner action	
1805 1,840*	1805 1,840*	Requesting publication of SIR after Examiner action	
1251 110	2251 55	Extension for reply within first month	
1252 420	2252 210	Extension for reply within second month	
1253 950	2253 475	Extension for reply within third month	
1254 1,480	2254 740	Extension for reply within fourth month	
1255 2,010	2255 1,005	Extension for reply within fifth month	
1401 330	2401 165	Notice of Appeal	
1402 330	2402 165	Filing a brief in support of an appeal	
1403 290	2403 145	Request for oral hearing	
1451 1,510	1451 1,510	Petition to institute a public use proceeding	
1452 110	2452 55	Petition to revive - unavoidable	
1453 1,330	2453 665	Petition to revive - unintentional	
1501 1,330	2501 665	Utility issue fee (or reissue)	
1502 480	2502 240	Design issue fee	
1503 640	2503 320	Plant issue fee	
1460 130	1460 130	Petitions to the Commissioner	
1807 50	1807 50	Processing fee under 37 CFR 1.17(q)	
1808 180	1808 180	Submission of Information Disclosure Stmt	
8021 40	8021 40	Recording each patent assignment per property (times number of properties)	
1809 770	2809 385	Filing a submission after final rejection (37 CFR 1.129(a))	
1810 770	2810 385	For each additional invention to be examined (37 CFR 1.129(b))	
1801 770	2801 385	Request for Continued Examination (RCE)	
1802 900	1802 900	Request for expedited examination of a design application	

Other fee (specify)

*Reduced by Basic Filing Fee Paid

SUBTOTAL (3) (\$) 0.00**SUBMITTED BY**

Name (Print/Type)	Winston Hsu	Registration No. (Attorney/Agent)	41,526	Telephone	886289237350
Signature	<i>Winston Hsu</i>	Date	8/27/2004		

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mu-Jung Wu, Ming-Yen Chung
5 Filing Date: 12/22/2003
APPL No.: 10/707,561
Docket No.: LKSP0034USA
Art Unit: 2812

**RECEIVED
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10 Title: Wafer Grinding Apparatus

To: Commissioner for Patents
P.O. Box 1450
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Subject: Information disclosure statement under
37C.F.R. §1.56 and 37C.F.R. §1.97(b).

Dear Sir:

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This is an Information Disclosure Statement in
accordance with the duty to disclose information
material to patentability under 37 C.F.R. §1.56. The
applicants wish to make of record the documents listed
25 on the accompanying form PTO/SB/08. It is respectfully
requested that the Examiner initials the cited
references on the form and that it be made of record
in the application and that a copy of the initialed
form be sent to the applicants with the next
30 communication from the Examiner.

Since the IDS is filed before the mailing date of

a first Office action on the merits, consideration of the information disclosure statement is hereby requested according to 37C.F.R. §1.97(b). The prior art patent contained in the information disclosure statement was cited in communications from the Taiwan Intellectual Property Office on June 21, 2004. The applicants sincerely hope that the Examiner can consider the item contained in the information disclosure statement.

10

According to the requirement set forth in 37C.F.R. §1.98 and M.P.E.P. 609, the applicants are submitting a copy of each of the cited references (Taiwan Patent No. 490359 and Japanese Patent No. 11-285967) and a concise explanation of the cited reference hereinafter.

Taiwan Patent No. 490359 discloses a method of grinding a semiconductor wafer using a grinding machine having a chuck table for holding a semiconductor wafer and a grinding means for grinding the top surface of a semiconductor wafer placed on the chuck table. The method comprises the step of holding the ground semiconductor wafer carried out from the chuck table after grinding by means of a wafer holding tray (Please refer to Fig.1 to Fig.6).

Japanese Patent No. 11-285967 discloses a washing water supply mechanism capable of supplying washing water to a surface of suction pad, and a supply nozzle capable of blowing pressured gas to the surface thereof for cleaning the surface of suction pad thereof (Please

refer to Fig.1).

Independent claim 1 of the present application is repeated here for reference:

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1. A wafer grinding apparatus comprising:
 - a wafer-transporting device for transporting a wafer comprising:
 - at least a suction pad having a first surface
 - 10 and a second surface, the second surface being flexible for sucking the wafer; and
 - a transporting mechanism connected to the first surface of the suction pad for transporting the wafer;
 - 15 a first nozzle for ejecting a first liquid to the first surface of the suction pad for cleaning the first surface; and
 - a second nozzle for ejecting a second liquid to the second surface of the suction pad and the wafer
 - 20 for cleaning the second surface and the wafer.

Compared with Taiwan Patent No. 490359, the present application wafer grinding apparatus utilizes at least a suction pad, which is included in a

25 wafer-transporting device of a wafer grinding apparatus, to transfer a wafer in the wafer grinding apparatus. On the other hand, Taiwan Patent No. 490359 utilizes a wafer holding tray to support a wafer and transfer the wafer out of a grinding apparatus.

30 Therefore, it is not able for the wafer holding tray to transfer wafers in the wafer grinding apparatus according to the method disclosed by Taiwan Patent No.

490359.

Compared with Japanese Patent No. 11-285967, the present application wafer grinding apparatus utilizes a second nozzle for ejecting a second liquid to a second surface of a suction pad and a wafer for cleaning the second surface and the wafer. Japanese Patent No. 11-285967 utilizes a washing water supply mechanism capable of supplying washing water to a surface of suction pad, and a supply nozzle capable of blowing pressured gas to the surface thereof for cleaning the surface of suction pad thereof. Therefore, it is not capable of cleaning a wafer by the device disclosed by Japanese Patent No. 11-285967.

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Since claim 1 of the present application is substantially different from Taiwan Patent No. 490359, Japanese Patent No. 11-285967, and even the combination of Taiwan Patent No. 490359 and Japanese Patent No. 11-285967, and all other claims are dependent on claim 1, a quick allowance of the present application is sincerely requested.

25

30

Respectfully Submitted,

5 Winston Hsu

Date: 8/27/2004

Winston Hsu, Patent Agent

Registration No.: 41,526

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(Please contact me by e-mail if you need a telephone
communication and I will return your call promptly)

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